

United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria. Virginia 22313-1450

AT	TORNEY DOCKET NO.	CONFIRMATION NO
	0756-2092	5586
	EXAM	INER

FIRST NAMED INVENTOR FILING DATE APPLICATION NO. 01/12/2000 Koichiro Tanaka 09/481,396 10/06/2003 31780 7590 **ERIC ROBINSON** PMB 955 PAPER NUMBER ART UNIT 21010 SOUTHBANK ST. 2828 POTOMAC FALLS, VA 20165 DATE MAILED: 10/06/2003

Please find below and/or attached an Office communication concerning this application or proceeding.

ME	/
----	---

•	Application No.	Applicant(s)			
•	09/481,396	TANAKA, KOICHIRO			
Office Action Summary	Examiner	Art Unit			
	Armando Rodriguez	2828			
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the o	correspondence address			
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, - Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be till within the statutory minimum of thirty (30) day rill apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	mely filed ys will be considered timely. In the mailing date of this communication. ED (35 U.S.C. § 133).			
Status	4 0000				
1) Responsive to communication(s) filed on 29 A					
,_	s action is non-final.				
3) Since this application is in condition for allowal closed in accordance with the practice under a Disposition of Claims					
4)⊠ Claim(s) 1-37 is/are pending in the application					
4a) Of the above claim(s) is/are withdrawn from consideration.					
5) Claim(s) is/are allowed.	William consideration.				
6) Claim(s) <u>1-37</u> is/are rejected.		Jane of			
7) Claim(s) is/are objected to.		PAUL IP			
8) Claim(s) are subject to restriction and/or		RVISORY PATENT EXAMINER CHNOLOGY CENTER 2800			
Application Papers	16	Office Court of Court			
9) The specification is objected to by the Examine	r.				
10)☐ The drawing(s) filed on is/are: a)☐ accep	oted or b) objected to by the Exa	ıminer.			
Applicant may not request that any objection to the	e drawing(s) be held in abeyance. S	See 37 CFR 1.85(a).			
11)☐ The proposed drawing correction filed on is: a)☐ approved b)☐ disapproved by the Examiner.					
If approved, corrected drawings are required in rep	ly to this Office action.				
12) The oath or declaration is objected to by the Ex	aminer.				
Priority under 35 U.S.C. §§ 119 and 120					
13) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).					
a)⊠ All b)□ Some * c)□ None of:					
1. Certified copies of the priority documents have been received.					
2. Certified copies of the priority documents have been received in Application No					
3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).					
* See the attached detailed Office action for a list of the certified copies not received.					
· · ·	14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).				
 a) ☐ The translation of the foreign language pro 15) ☐ Acknowledgment is made of a claim for domesting the compact of the compact					
Attachment(s)					
Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO-1449) Paper No(s)	5) 🔲 Notice of Informal	y (PTO-413) Paper No(s) Patent Application (PTO-152)			

Application/Control Number: 09/481,396

Art Unit: 2828

DETAILED ACTION

Continued Examination Under 37 CFR 1.114

A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on June 30, 2003 has been entered.

Allowable Subject Matter

The indicated allowability of claims 1,4,10-12,17-20 and 31-34 is withdrawn in view of the newly discovered reference(s) to Yamazaki et al. Rejections based on the newly cited reference(s) follow.

Claim Rejections - 35 USC § 112

The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

Claims 3,6,13-16, 24-26 and 35-37 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

Claim 3 and 13 are rejected under 35 U.S.C. 112, second paragraph, as being incomplete for omitting essential elements, such omission amounting to a gap between the elements. See MPEP § 2172.01. The omitted elements are: no structure has been recited for shielding the lens.

Application/Control Number: 09/481,396

Art Unit: 2828

Regarding claims 3 and 13,

It is not clear within the claim language, what applicant refers to as "outer side", since the structural arrangement of the cylindrical lenses have not been clearly defined.

It is clear within the claim language, how is the lens shielded?

It is not clear within the claim language, what the lens is shielded from?

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1,2,7,9,10-12 are rejected under 35 U.S.C. 103(a) as being unpatentable over Yamazaki et al.

Regarding claims 1,2,7,9,10,12,17,21,27,31,

Figure 2A of Yamazaki et al illustrates a laser system for irradiating a semiconductor substrate having a laser (201), cylindrical lens group (202) and (203) for dividing the laser beam, a cylindrical lens (204) for combining the divided beams and slit, which will provide the laser beam with edges, as described in the abstract and paragraph [0032] – [0035] and figure 11A illustrates the substrate. Figure 2A illustrates the output beam as having a width wider than the cylindrical lens.

Yamazaki does not disclose positioning the slit between the cylindrical lens and the laser source.

Application/Control Number: 09/481,396

Art Unit: 2828

However, it would have been an obvious matter of design choice to arrange the slit within the laser system, since providing the slit at any position within the laser system the slit will provide the laser beam with edges, thereby the invention would perform equally well and irradiate the semiconductor film.

Regarding claims 4-6,8 and 11,

Yamazaki et al does disclose a cylindrical lens (204) and (206) for combining the divided beams.

Regarding claims 19,22,29,33,

Figure 9 illustrates the cylindrical lens (204) as a convex lens, as it is commonly known in the art.

Regarding claims 18,28,32,

The use of a slit made of metal is notoriously well known in the art.

Regarding claims 20,23,24,

It is well known in the art to use an excimer laser or YAG laser, which provide a harmonic wave for irradiating a substrate, as disclosed by Shirashi et al in column 26.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Armando Rodriguez whose telephone number is (703) 308-6218. The examiner can normally be reached on 10-hour day / M-F.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Paul Ip can be reached on (703) 308-3098. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Art Unit: 2828

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-

4881.

Armando Rodriguez

Examiner Art Unit 2828

AR/PI

Paul Ip Supervisor Art Unit 2828